Company Introduction

Park Systems

IR Team

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Introduction



- Park Systems is at the forefront of advanced nanotechnology, delivering innovative solutions enabling research and industry to achieve unprecedented precision and progress.
- Our state-of-the-art AFM technology facilitates breakthroughs across a broad spectrum of sectors — including semiconductors, biotechnology, and secondary battery development — continually setting new benchmarks in accuracy and performance.

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Customers

- Park Systems' Atomic Force Microscopes (AFMs) are extensively used for nanoscale measurements by leading global universities, government-funded research institutes, corporate research centers, and major semiconductor and other business-related companies worldwide.



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Global Channels

- Park Systems boasts a significant global network, with offices and partners spanning in the Americas, Europe, Asia, and Oceania.



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Key Products and Services

- Park Systems supplies advanced AFMs and continues to enhance its metrology capabilities through the strategic acquisition of companies such as Accurion and Lyncée Tec.

- Material Science & Chemistry


FX40


NX10


NX-Hivac


FX200


NX20


NX12



- Semiconductor & Display


NX-Wafer

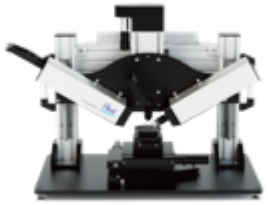

NX-Mask


NX-Hybrid WLI


NX-TSH

- Thin Film Characterization


Accurion EP4


Accurion SIMON


Accurion RSE

- Holography-based microscope


Lyncée Tec R2100


Lyncée Tec R2100

Park Systems
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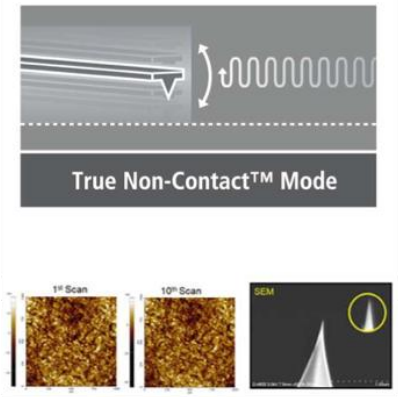
Innovative technology

- Monitoring the surface topography using **interaction**(Atomic Force) between the tip and the sample surface.
- Measuring the **Electrical, Mechanical, Magnetic, Thermal,** and **Topography** properties
- **True Non-Contact mode**, optimized for both research and industrial applications.



Measurement Accuracy

Park AFM Scanners
Decoupled XY & Z Scanners



Best Resolution

Park AFM Mode
True Non-Contact™ Mode



User Convenience

Park Operating Software
SmartScan™, SmartAnalysis™, XEA

Source : ParkSystems Youtube(https://www.youtube.com/watch?v=wiFCYFrXkek)

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History

- Park Systems was established by one of the original Atomic Force Microscope (AFM) developers to make the world's most precise nanoscale metrology and imaging instruments widely available.

The Birth-Place of AFM



Stanford University

1982-1988

The First AFM Company



Park Scientific Instruments

1988-1997



세계 최초 원자현미경 개발
실리콘밸리 성공 신화 주역
고국서 두 번째 '벤처 人生'

The AFM Technology Innovator

Park SYSTEMS

1997-Present

KOSDAQ LISTED COMPANY

2015



세계 2위, 국내 유일… 원자현미경 분야 '매운 고추'

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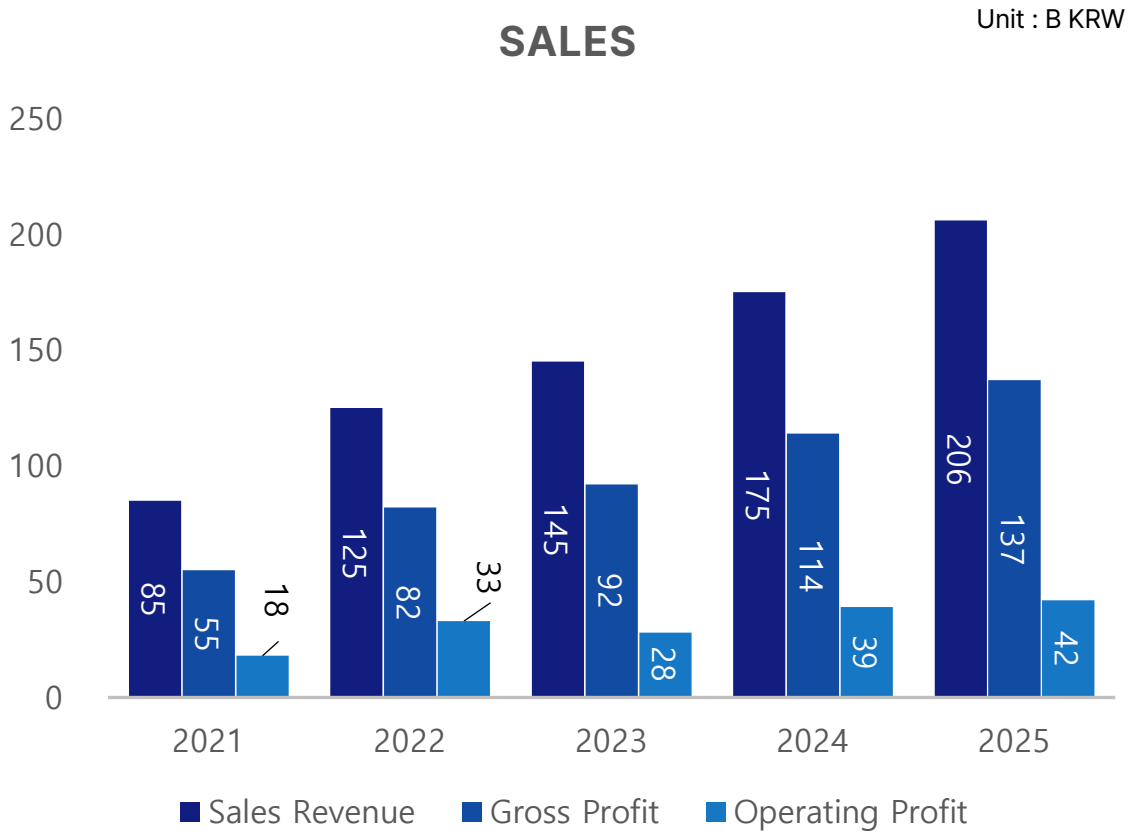
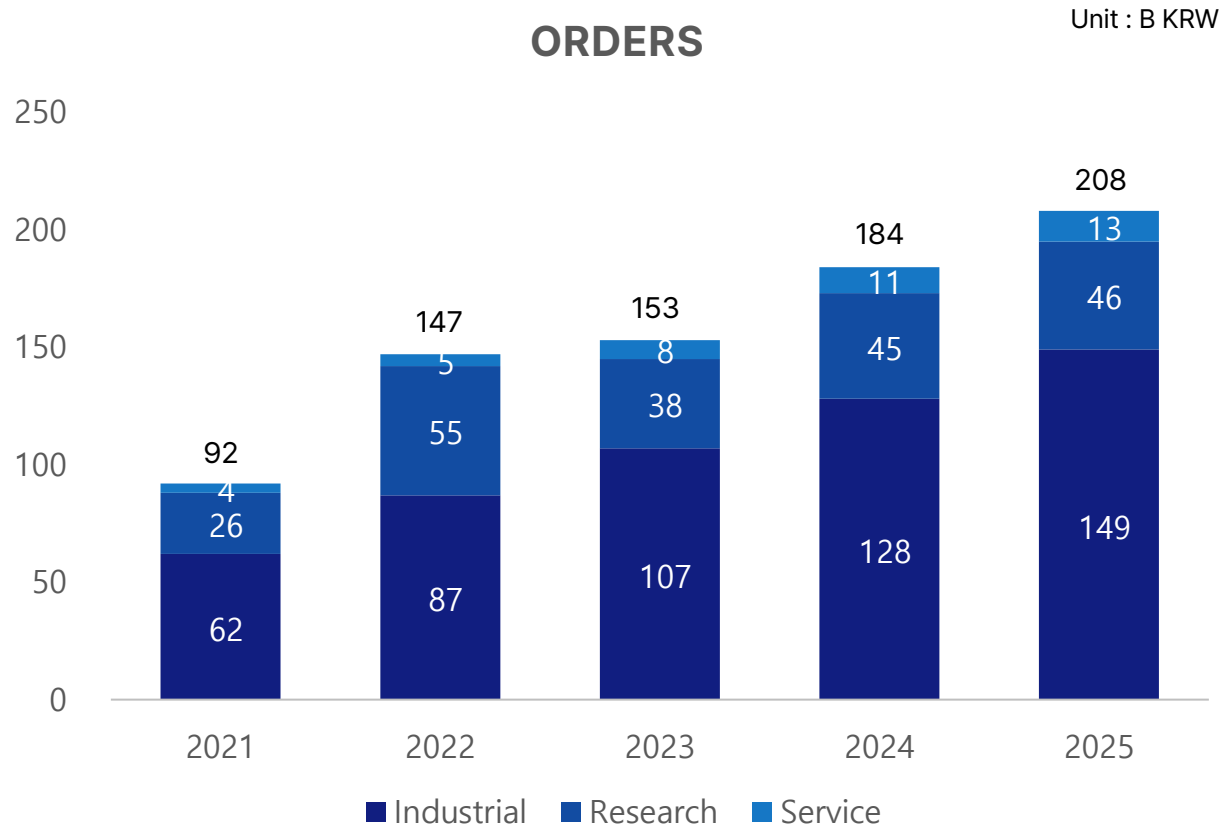
Sales and Orders for the Past 5 Years

- Park Systems has consistently experienced annual growth of 20-30%.
- Sales have steadily increased due to the rising demand for industrial equipment.



Note : K-IFRS consolidated financial statement basis



Note : K-IFRS consolidated financial statement basis

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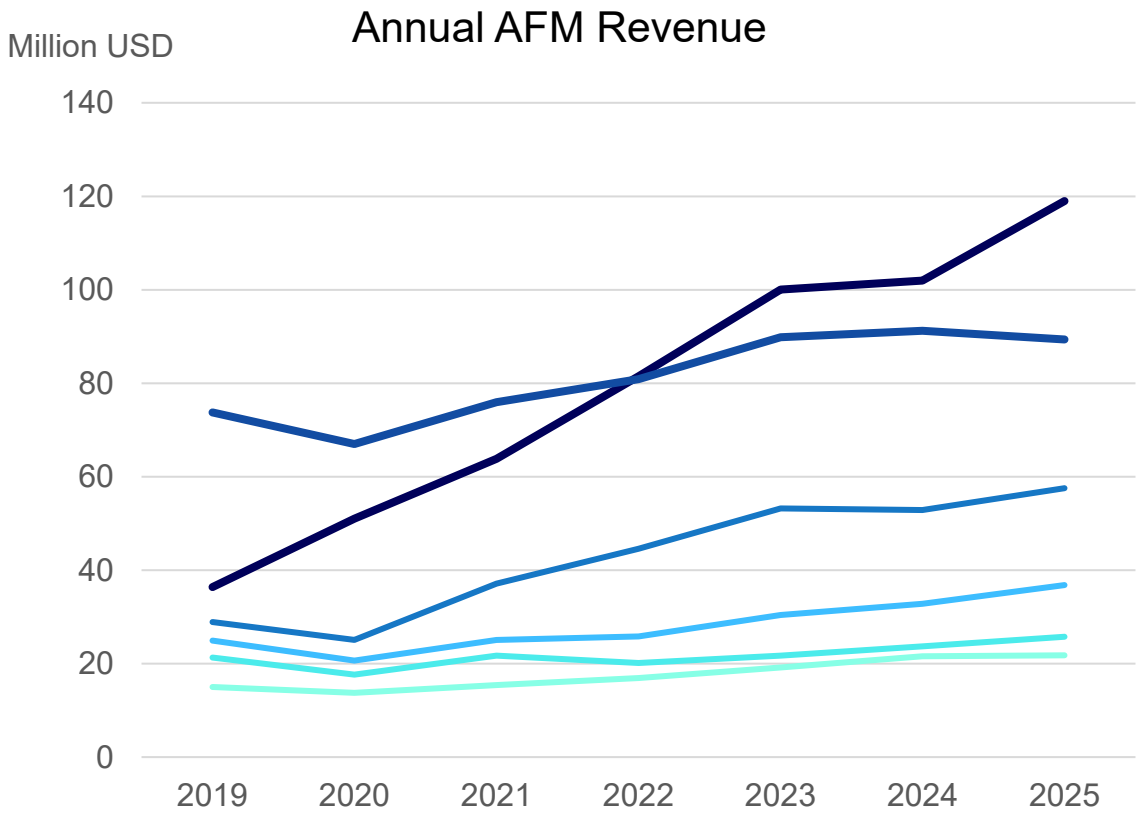
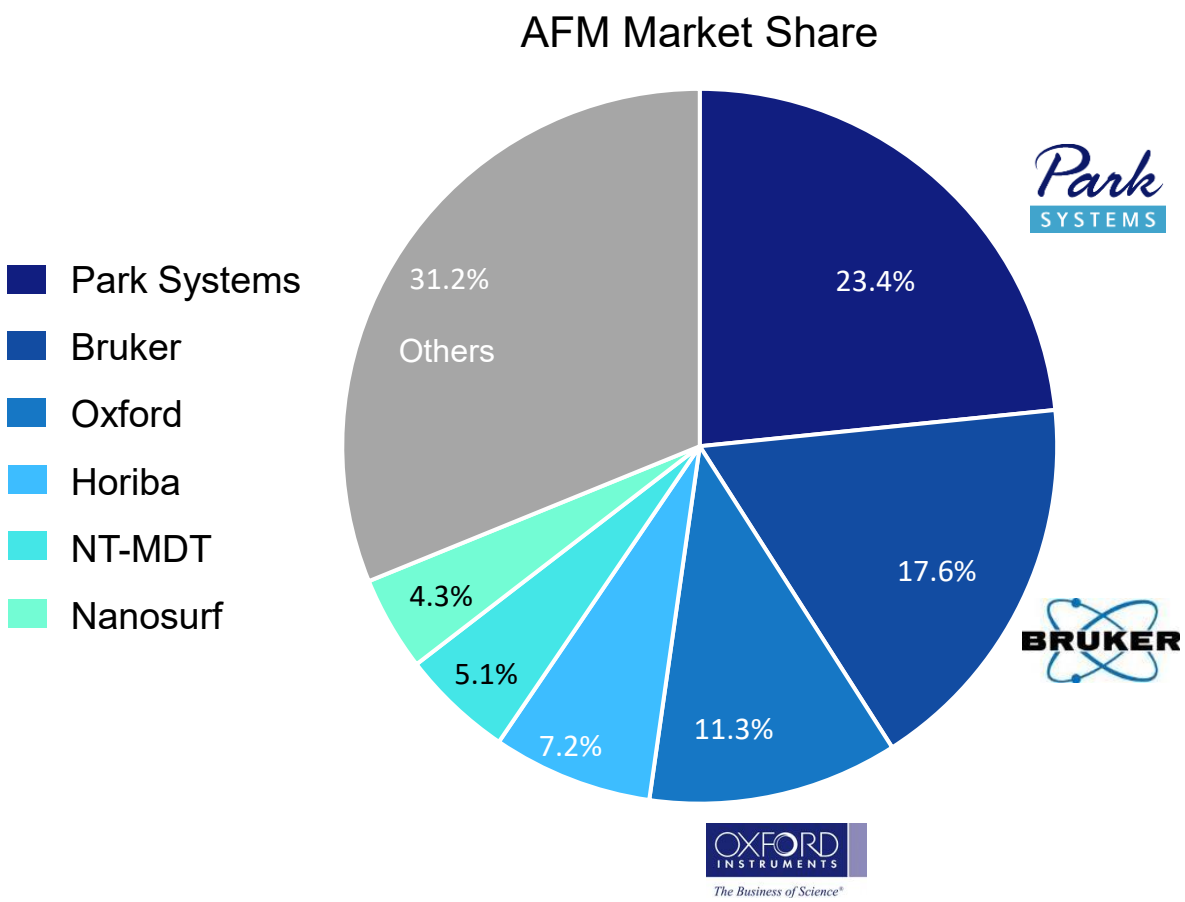
AFM Market

- Park Systems holds the No.1 position in the AFM market.
- The AFM market is expected to grow steadily, driven by increasing demand for industrial equipment.





Source: Above companies; Secondary sources, Expert interviews and QYResearch, 2026

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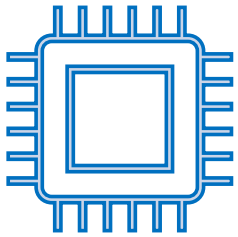
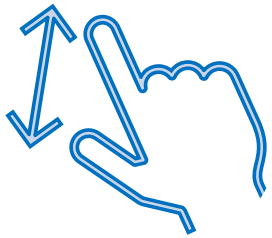
Market Opportunity

- Opportunities arising from the miniaturization of semiconductor processes.
- Potential for scalability to industries beyond semiconductors.



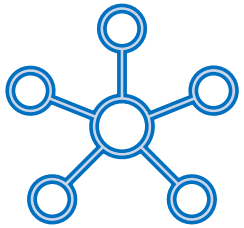
Miniaturization and Increasing Complexity



Increasing Utilization in Advanced Processes



Growing Applications in Back-End Processes



Expansion into Various industries

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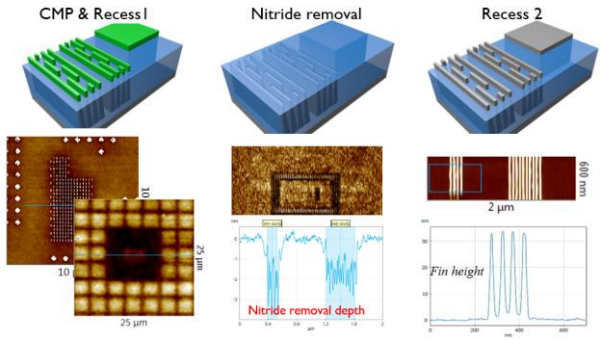
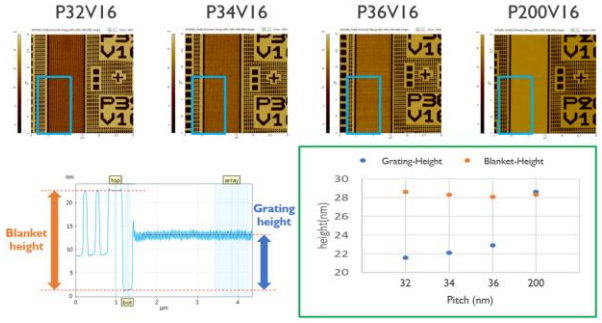
Market Opportunity

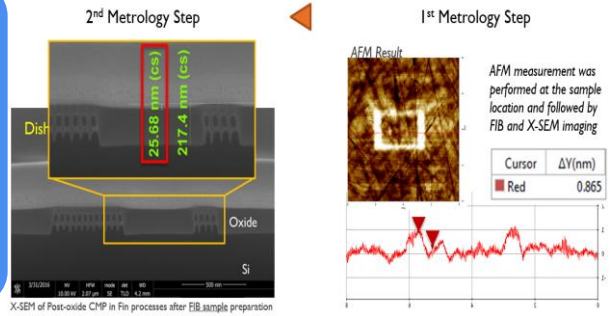
Fin/Gate process



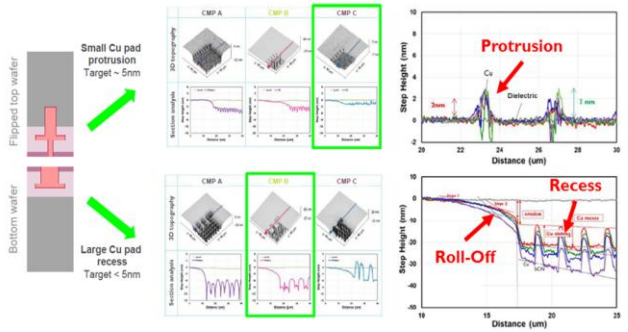
CD/LER/LWR for EUV



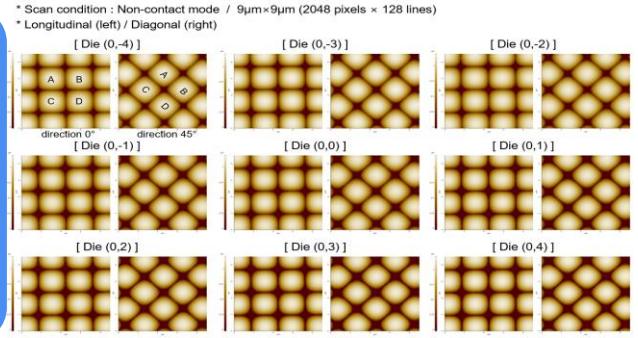
CMP process



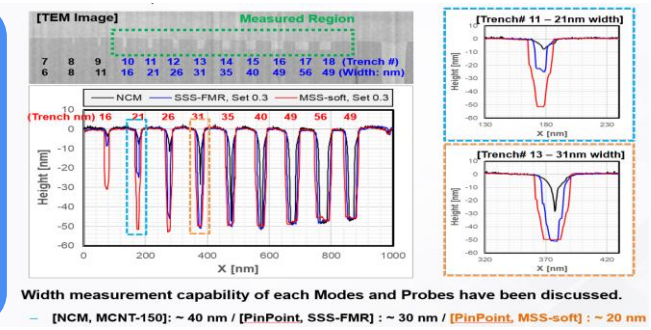
Wafer-to-wafer hybrid bonding



CMOS Image Sensor



Narrow trench structure



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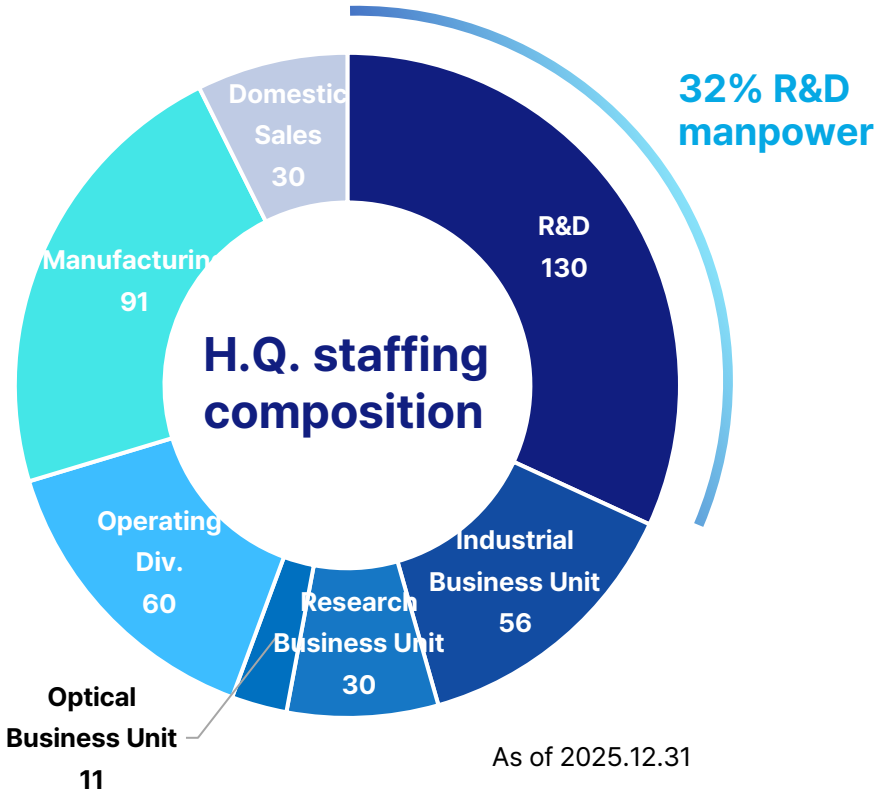
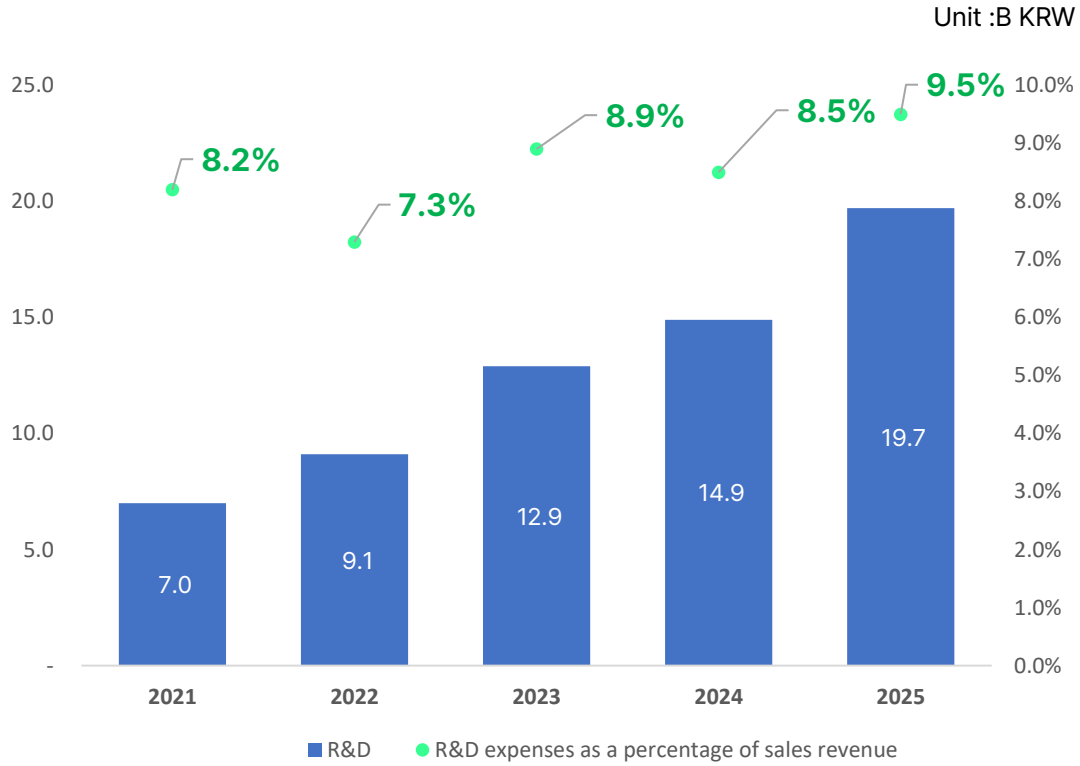
R&D

- Park Systems has been recognized for its top-tier research and development in nanoscale metrology.



As of 2025.12.31



Note : K-IFRS consolidated financial statement basis

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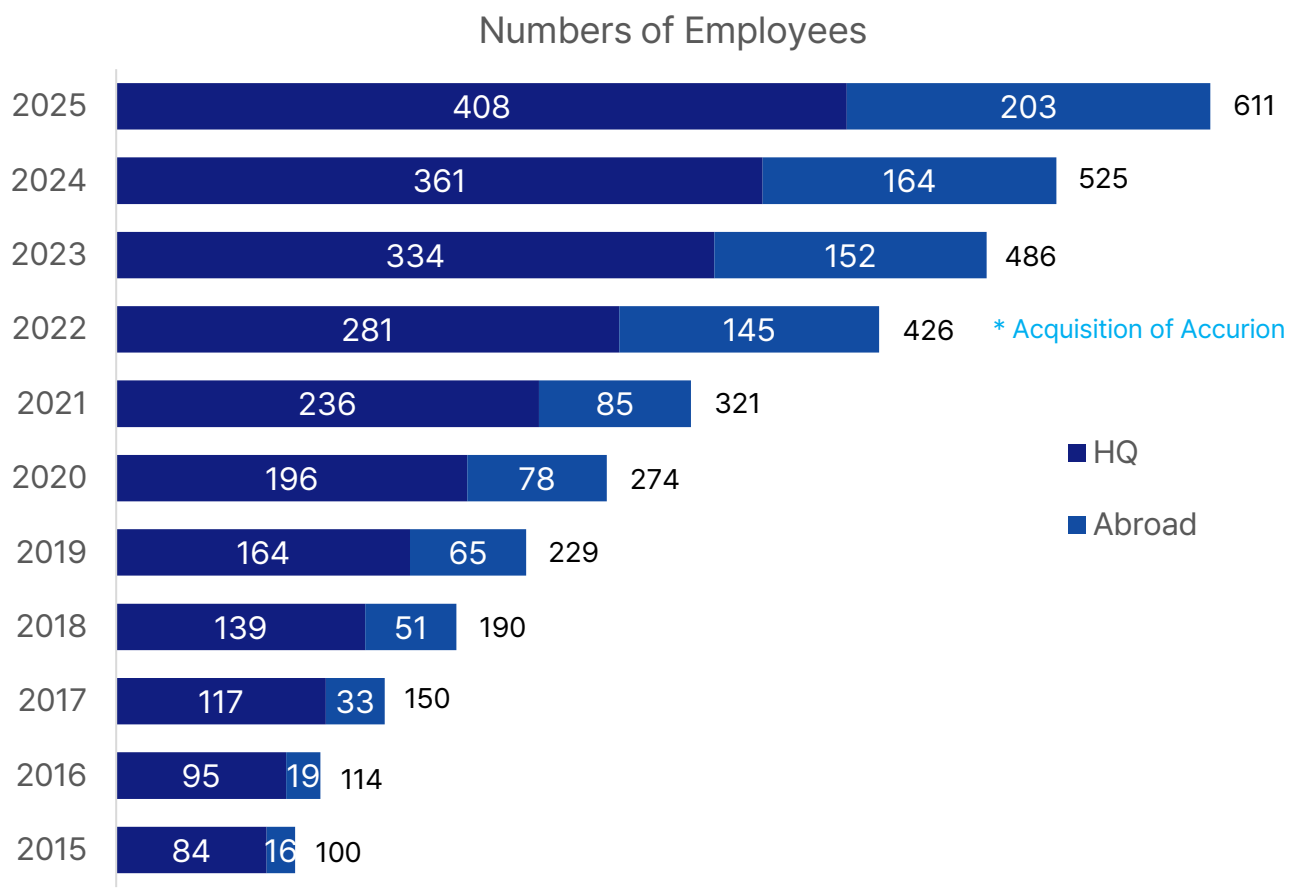
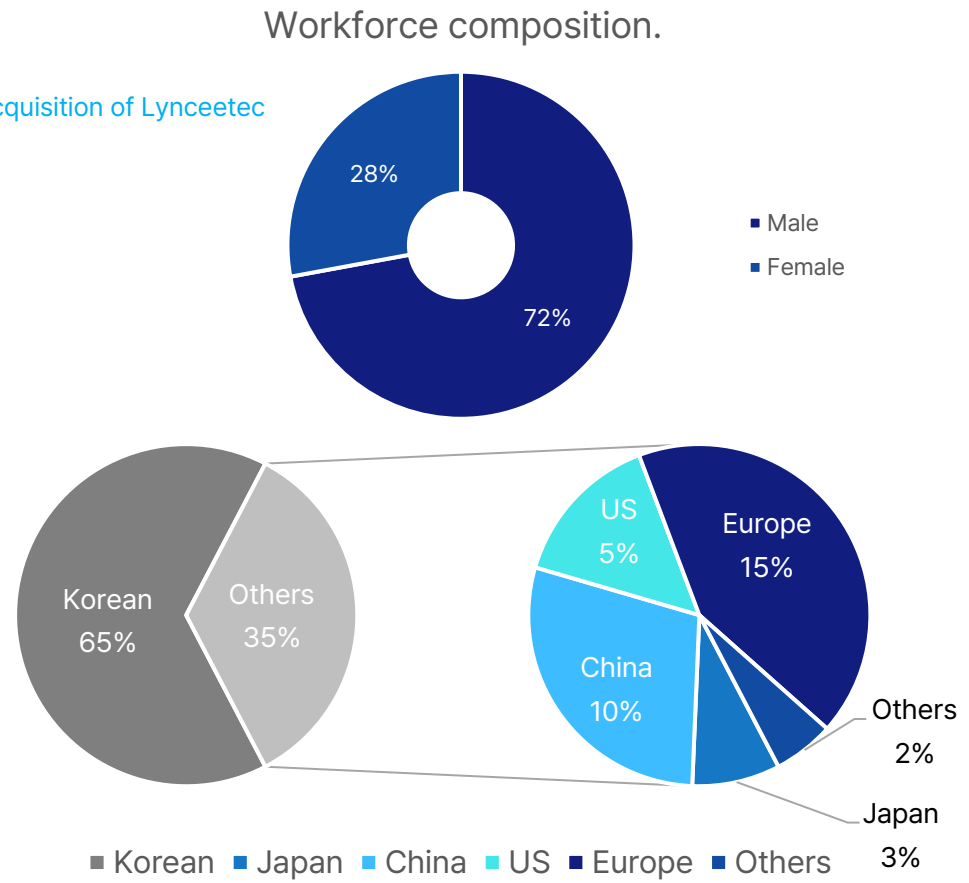
ESG-HR

- The workforce has steadily increased each year due to explosive growth.
- The company prioritizes diversity, emphasizing inclusion across gender and nationality.





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ESG-Board of Directors

- The Board of Directors consists of 1 CEO and 6 outside directors for decision-making transparency.



Sang-il Park Chairman

- CEO, Park Systems Corp. (1997~)
- President, Institute of Control, Robotics, and Systems (2024)
- CEO, Park Scientific Instruments (1988~1997)
- MBA, AEA-Stanford Executive Institute (1994)
- PhD, Applied Physics, Stanford University (1987)
- BS, Physics, Seoul National University (1981)

Compensation Committee



Jun Chung Outside director

- **Outside director of Park Systems(2023~)**
- CEO, SOLiD, Inc. (1998~)
- Adjunct Professor, KAIST Startup (2020~)
- Senior Researcher, Korea Telecom (1994~1998)
- PhD, Electrical Engineering, Stanford University (1993)
- BS, Electrical Engineering, Seoul National University (1986)



Ki-young Choi Outside director

- **Outside director of Park Systems(2025~)**
- Emeritus Professor,Seoul National University (2021~)
- Minister of Science and ICT, Republic of Korea (2019~2021)
- PhD, Electrical Engineering, Stanford University (1989)
- MS, Electrical and Electronic Engineering, KAIST (1980)
- BS, Electronic Engineering, Seoul National University (1978)



Tae Hea Nahm Outside director

- **Outside director of Park Systems (2026~)**
- Storm Ventures - Managing Director & Co-Founder (2000~)
- Venture Law Group - Partner & Co-Founder (1993~2000)
- Wilson Sonsini Goodrich and Rosati - Partner (1985~1993)
- University of Chicago - JD (1985)
- Havard University - AB, Applied Mathematics (1982)

Audit Committee



Kee-jun Park Outside director

- **Outside director of Park Systems(2024~)**
- CPA, Woori Accounting Firm (2020~)
- CEO, Kitus Co., Ltd. (2009~2019)
- CPA, Anjin Accounting Firm (1988~1997)
- PhD, Business Administration, University of Seoul (2011)
- BBA, Seoul National University (1989)



Hee-kook Lee Outside director

- **Outside director of Park Systems(2025~)**
- Advisor, LG Corp. (2020~2022)
- President & Chairman of Group Technology Council, LG Corp. (2012~2016)
- President, LG Electronics (2004)
- PhD, Electronic Engineering, Stanford University (1980)
- MS, Electronic Engineering, Stanford University (1977)
- BS, Electronic Engineering, Seoul National University (1974)



Soo-in Cho Outside director

- **Outside director of Park Systems(2026~)**
- Chair Professor at Dankook University (2023)
- President and CEO of Samsung Medison (2012–2015)
- President and Head of the OLED Business Division at Samsung Display (2012)
- President and CEO of Samsung Mobile Display (2010–2012)
- President and Head of the Memory Division at Samsung Electronics (2010)
- B.S. in Electronic Engineering from Seoul National University (1979)

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ESG-Dividend

- Dividend Policy to enhance shareholder Value
  - Priority is given to investment in both organic and inorganic growth.
  - Plans include share repurchase and dividend payouts.
  - Dividends are expected to range between 10% and 50% of Free Cash Flow (FCF)

	Unit	2021	2022	2023	2024	**2025**
Earnings per Share	KRW	1,508	3,258	3,786	5,614	**4,951**
Dividend per share	KRW	250	400	400	500	**500**
Free Cash Flow (A)	M KRW	3,693	17,020	17,080	26,782	**9,586**
Total dividend (B)	M KRW	1,717	2,761	2,768	3,470	**3,476**
Payout ratio (B/A)	%	46%	16%	16%	13%	**36%**

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ESG-Safety & Environment

- Park Systems is continuously obtaining certifications for environmental and safety standards.



Certification No. ISCEM-0291

Environmental Management System Certificate

Park Systems Corp.

KANC 4F, Gwanggyo-ro 109, Yeongtong-gu, Suwon-si, Gyeonggi-do, Korea

This is to certify that the Environment Management System of the above company is appropriate to the standard and the scope listed below, in accordance with registration system provision of this certification body.

Certification Standard :

KS I ISO 14001:2015 / ISO 14001:2015

Certification Scope :

The Design/Development, Production of Scanning Probe Microscope.

DATE OF INITIAL REGISTRATION	DATE OF EXPIRY	DATE OF LAST ISSUE
25 JULY 2005	24 JULY 2023	07 JULY 2021

y. c. kwon

International Standard Certification Co., LTD
Authorised Signatory

The accreditation mark indicates that ISC has been accredited as one of certification bodies (NO. KAB-EC-26) for ISO14001 by KAB.

804ho, 12, Ojosan-ro 45beon-gil, Gyeyang-gu, Incheon, Korea TEL.+82-32-552-1205



Certification No. ISCQM-0568

Quality Management System Certificate

Park Systems Corp.

KANC 4F, Gwanggyo-ro 109, Yeongtong-gu, Suwon-si, Gyeonggi-do, Korea

This is to certify that the Quality Management System of the above company is appropriate to the standard and the scope listed below, in accordance with registration system provision of this certification body.

Certification Standard :

KS Q ISO 9001:2015 / ISO 9001:2015

Certification Scope :

The Design/Development, Production of Scanning Probe Microscope.

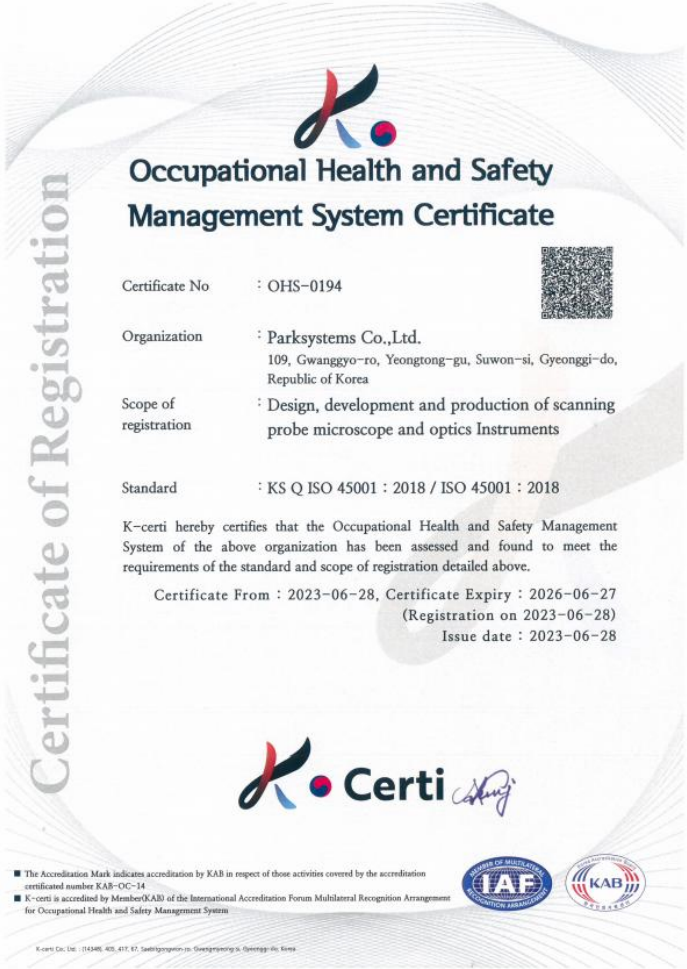
LATEST ISSUE	EXPIRY DATE
25 JULY 2024	24 JULY 2025
INITIAL CERTIFICATION	RE-CERTIFICATION BEFORE
25 JULY 2008	24 JULY 2026

Gil Youngseok

International Standard Certification Co., LTD
Authorised Signatory

The accreditation mark indicates that ISC has been accredited as one of certification bodies (NO. KAB-QC-28) for ISO9000 by KAB.

804ho, 12, Ojosan-ro 45beon-gil, Gyeyang-gu, Incheon, Korea TEL.+82-32-552-1205



Certificate of Registration

Occupational Health and Safety Management System Certificate

Certificate No	: OHS-0194
Organization	: Parksystems Co.,Ltd. 109, Gwanggyo-ro, Yeongtong-gu, Suwon-si, Gyeonggi-do, Republic of Korea
Scope of registration	: Design, development and production of scanning probe microscope and optics Instruments
Standard	: KS Q ISO 45001 : 2018 / ISO 45001 : 2018

K-certi hereby certifies that the Occupational Health and Safety Management System of the above organization has been assessed and found to meet the requirements of the standard and scope of registration detailed above.

Certificate From : 2023-06-28, Certificate Expiry : 2026-06-27
(Registration on 2023-06-28)
Issue date : 2023-06-28

K-certi

■ The Accreditation Mark indicates accreditation by KAB in respect of those activities covered by the accreditation certificated number KAB-OC-14
■ K-certi is accredited by Member(KAB) of the International Accreditation Forum Multilateral Recognition Arrangement for Occupational Health and Safety Management System

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Appendix

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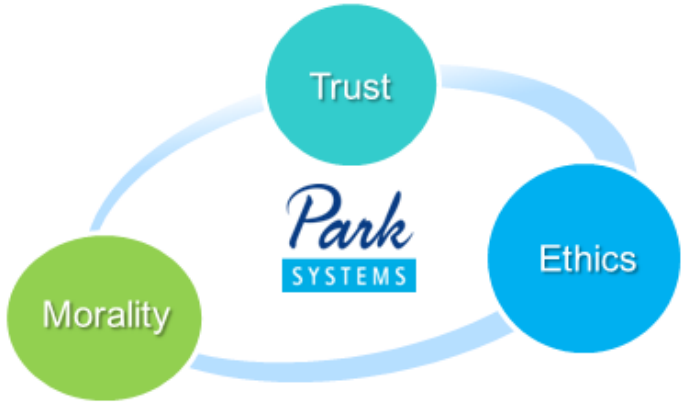
Company Overview

Company Status

Company	Park Systems Corp.
CEO	Sang-il Park
Established	April 7, 1997
Capital	3,498m (KRW) (As of Dec, 2025)
Employees	611 (As of Dec, 2025)
Business field	Precision Instrument Manufacturing
Product	Atomic Force Microscope
Location	KANC 4F, Gwanggyo-ro 109, Yeongtong-gu, Suwon, 16229, Korea
Website	http://www.parksystems.com

Business Philosophy



1. Become the one who receives compliments from people and descendants.
2. Provide maximum value to customers, shareholders, employees and business partners, furthermore, become a company that provides benefits to both companies and the society.
3. Excel in technical development and global marketing.
4. Trust is the best asset, and moral and ethical management are basic.

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Key driver for sustainable growth

- Park Systems drives sustainable growth through continuous innovations in nanotechnology.



Market

- Growth potential with advancing nanotechnology
- A stable market with a long technology lifecycle



Technology

- World-class technology that's difficult to replicate
- National core technology that cannot be leaked



Product

- A product with top-tier competitiveness
- High-value-added product



Global Business

- Global market expansion through own brand and sales network



Customers

- Supplies to leading universities, research institutes, and companies worldwide
- High customer satisfaction



Employee

- Passionate and loyal high-caliber talents

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Management Team



Sang-il Park Founder and CEO

- CEO, Park Systems Corp. (1997~)
- President, Institute of Control, Robotics, and Systems (2024)
- CEO, Park Scientific Instruments (1988~1997)
- MBA, AEA-Stanford Executive Institute (1994)
- PhD, Applied Physics, Stanford University (1987)
- BS, Physics, Seoul National University (1981)



Ryan Yoo EVP

Business Development & Strategic Growth BU

19yrs at Park Systems, 24yrs overall

- Intematix Corp. VP, Founding Scientist and VP of R&D
- Ph.D. Physics, UC Berkeley
- B.S. Physics, Univ. of Chicago



Karen Cho EVP

Operations Management Div.

21yrs at Park Systems, 30yrs overall

- Solborn, Inc. Gyelim CRC, Inc.
- Hanareum Merchant Bank
- Hanhwa Merchant Bank
- MBA, KAIST
- B.A. English literature, Sejong Univ.



Sang-Joon Cho EVP

Research Equipment BU

19yrs at Park Systems, 24yrs overall

- Korea R&D Industry Association, Board of Directors
- ISO/TC201/SC9 SPM,Chairman
- KAIST, Dept of biosystems, Research Professor
- Research Associate, Dept. of Physiology, Univ. of Wayne
- Ph.D. Neuroscience, Iowa-state Univ.



Richard Lee EVP

Industrial Equipment BU

3yrs at Park Systems, 24yrs overall

- Nanometrics Korea, VP of Marketing
- KLA-Tencor, Wafer Inspection Div. Marketing Dir.
- Samsung Electronics – Team Leader of Metrology and Inspection
- Ph.D. Mech Eng, KAIST

R&D Organization

Sang-il Park holds a dual role as CTO.

- System R&D Center
  - Mechatronics
  - Systems Integration
  - Development Planning Development Transfer
- Digital R&D Center
  - SW R&D
  - Control Electronics
- Advanced R&D Center
  - New Technology R&D
  - Prototyping

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Awards & Certification

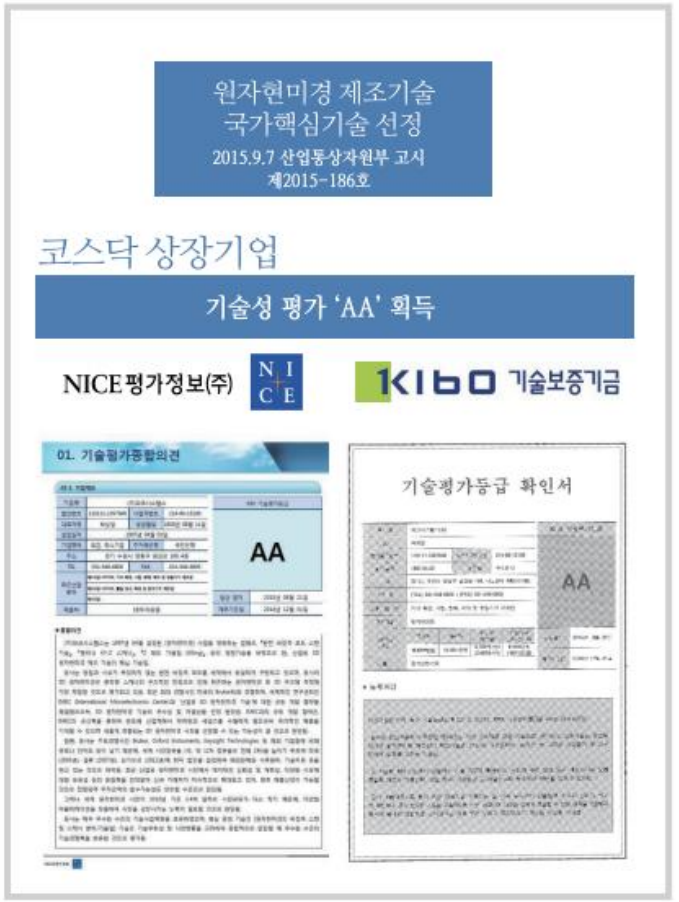
- Park Systems has received prestigious awards and obtained top-level technology certifications.



- KOSDAQ Grand Prize



- 2024 IR Grand Prize



- National Core Technology
- AA in Technology Assessment

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Financial Statements

- Park Systems continues to experience annual growth of 20-30%.
- Park Systems achieves high-profit margins by supplying high-value-added products.

Unit : M KRW

B/S	2022	2023	2024	2025	2026 H1
Current assets	126,307	148,107	191,151	196,653	**264,878**
Non-current assets	40,742	53,566	83,164	153,269	**209,029**
Total asset	167,049	201,673	274,315	349,922	**473,907**
Current liabilities	39,688	49,665	62,938	73,354	**73,180**
Non-current liabilities	7,898	8,523	23,468	51,449	**60,422**
Total Liabilities	47,586	58,188	86,406	124,803	**133,602**
Capital	3,474	3,483	3,494	3,498	**3,501**
Additional paid in capital	48,146	49,189	50,814	51,809	**159,389**
Others	(1,692)	(523)	2,229	7,436	**10,794**
Retained earnings	69,535	91,336	131,372	162,376	**166,621**
Total equity	119,463	143,485	187,909	225,119	**340,305**

Note : K-IFRS consolidated financial statement basis

Unit : M KRW

I/S	2022	2023	2024	2025	2026 H1
Sales Revenue	124,522	144,806	175,060	205,613	**92,400**
Cost of goods sold	43,053	52,401	60,842	69,121	**29,018**
Operating expenses	48,821	64,845	75,688	94,301	**57,067**
Operating profit	32,648	27,560	38,530	42,191	**6,315**
Non-operating profit	11,332	6,662	14,788	11,614	**7,738**
Non-operating expenses	12,099	7,079	6,088	12,581	**4,754**
Profit before tax	31,881	27,143	47,230	41,224	**9,299**
Tax expenses	3,897	2,581	4,427	6,748	**1,580**
Net income	27,984	24,562	42,803	34,476	**7,719**

Note : K-IFRS consolidated financial statement basis

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Patents

- Domestic and international patents in the field of atomic force microscopy

Division	Contents	Registration date
Patent	ATOMICFORCEMICROSCOPEEQUIPPEDWITHOPTICALMEASUREMENT DEVICEANDMETHODOFACQUIRINGINFORMATIONONSURFACEOFMEASUREMENTTARGETUSINGTHESAME	2023-04-04
Patent	MEASURING METHOD FOR MEASURING HEAT DISTRIBUTION OF SPECIFIC SPACE USING STHM PROBE, METHOD AND DEVICE FOR DETECTING BEAM SPOT OF LIGHT SOURCE	2023-03-21
Patent	An apparatus and method for recognizing a target position in an AFM	2023-03-08
Patent	A method for measuring the heat distribution in a specific space using a thermal sensing probe, a method for detecting a beam spot of a light source, and a device	2022-12-09
Patent	Devices and methods for recognizing probe types in an AFM	2022-11-04
Patent	A method for measuring the heat distribution in a specific space using a thermal sensing probe, a method for detecting a beam spot of a light source, and a device	2022-06-27
Patent	An AFM equipped with an optical measurement device and a method of obtaining information on the surface to be measured using it	2022-06-13
Patent	How to obtain the properties of the surface of the measurement target using an inclined tip, an AFM for this method to be performed, and a computer program stored in a storage medium to perform this method	2021-12-24
Patent	Chip carrier exchanging device and atomic force microscopy apparatus having same	2021-11-16
Patent	AFM and control methods capable of automatic exchange of chip carriers	2020-11-25

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Ver. 251114

‘26 Q2 Earnings Presentation

Park Systems

IR Team

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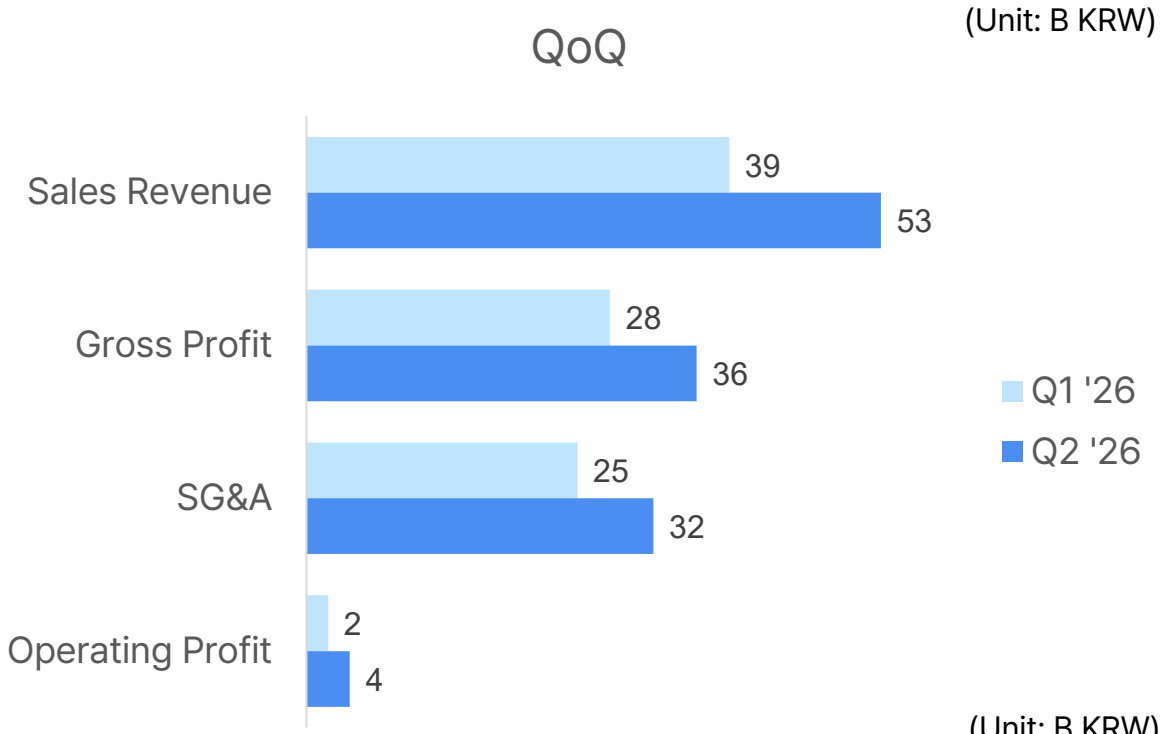
Q2 ‘26 Performance

(Unit: B KRW)

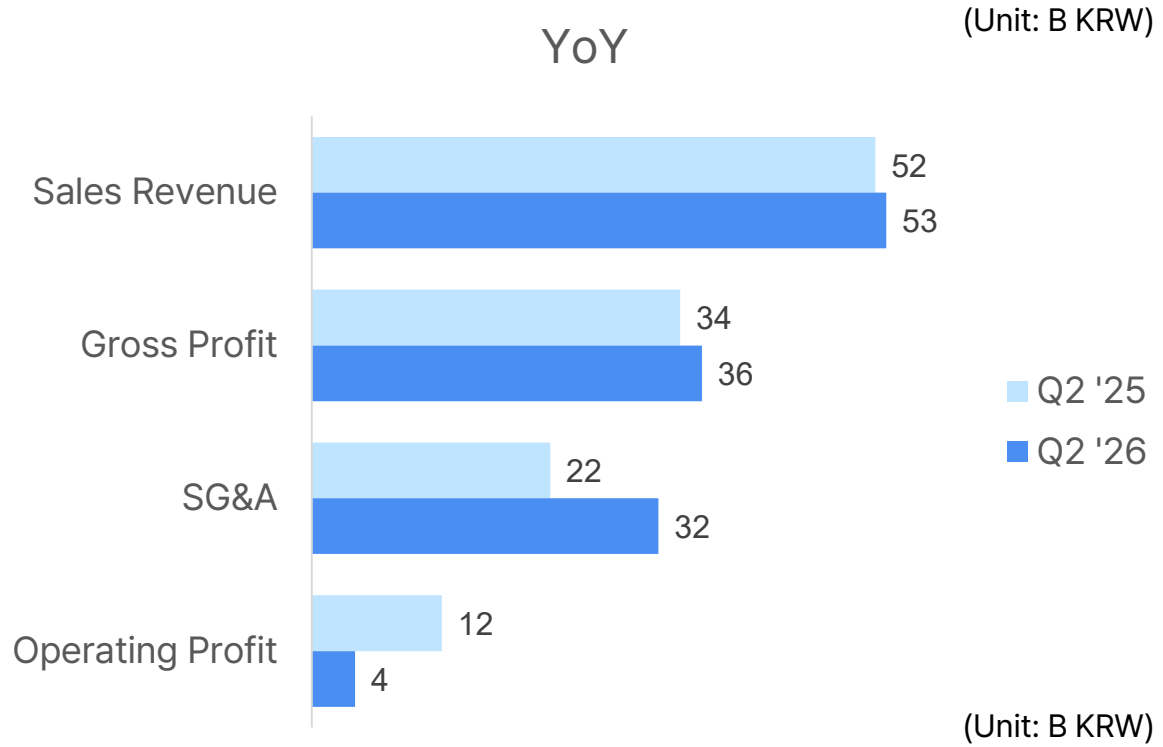


(Unit: B KRW)

	Sales Revenue	Gross Profit	SG&A	Operating Profit
Q1 ‘26	39	28	25	2
Q2 ‘26	53	36	32	4
QoQ(%)	35%	30%	24%	100%

Note : K-IFRS consolidated financial statement basis

(Unit: B KRW)



(Unit: B KRW)

	Sales Revenue	Gross Profit	SG&A	Operating Profit
Q2 ‘25	52	34	22	12
Q2 ‘26	53	36	32	4
YoY(%)	1%	5%	42%	(65%)

Note : K-IFRS consolidated financial statement basis

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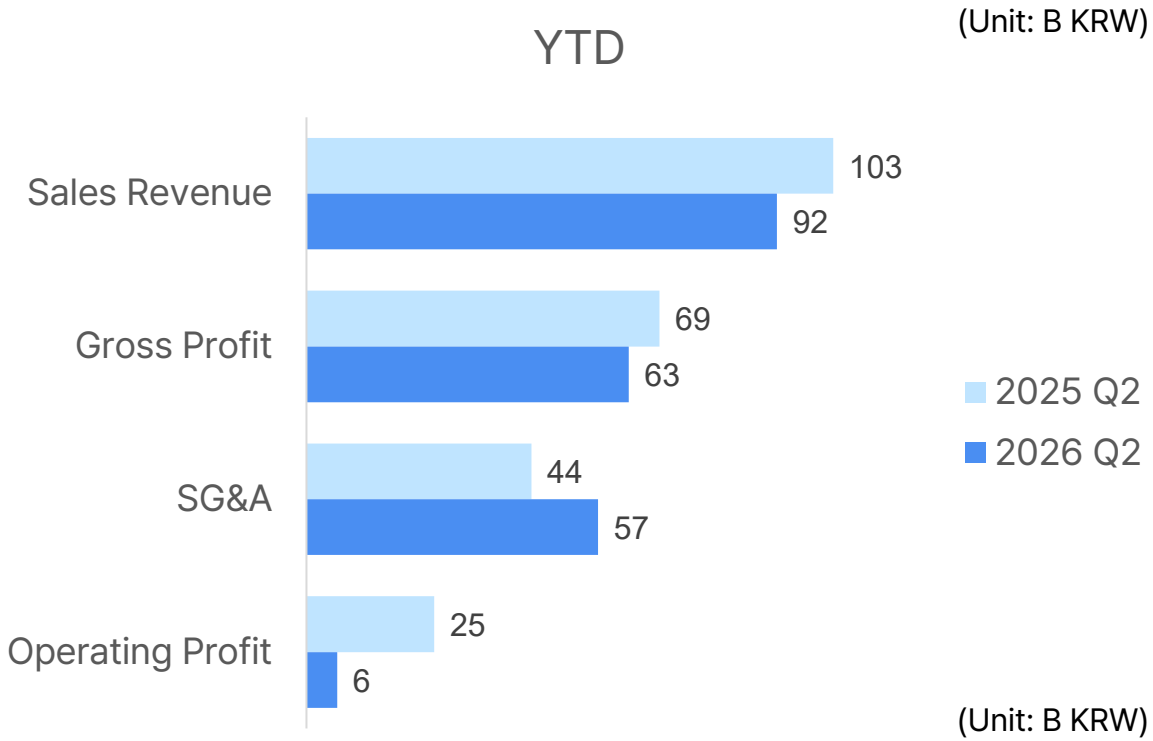
2026 YTD Performance

(Unit: B KRW)



(Unit: B KRW)

	Sales Revenue	Gross Profit	SG&A	Operating Profit
2025 Q2	103	69	44	25
2026 Q2	92	63	57	6
YoY(%)	(10%)	(9%)	29%	(75%)

Note : K-IFRS consolidated financial statement basis

- Revenue decreased by 10% YoY due to weak shipments of industrial equipment in Q2
- Gross profit decreased by 9% YoY, while gross profit margin (GPM) improved to 68%
- SG&A expenses increased by 29% YoY, mainly due to higher R&D expenses, personnel costs, and sales commissions
- Operating profit decreased by 75% YoY due to higher SG&A expenses, with operating profit margin (OPM) at 7%

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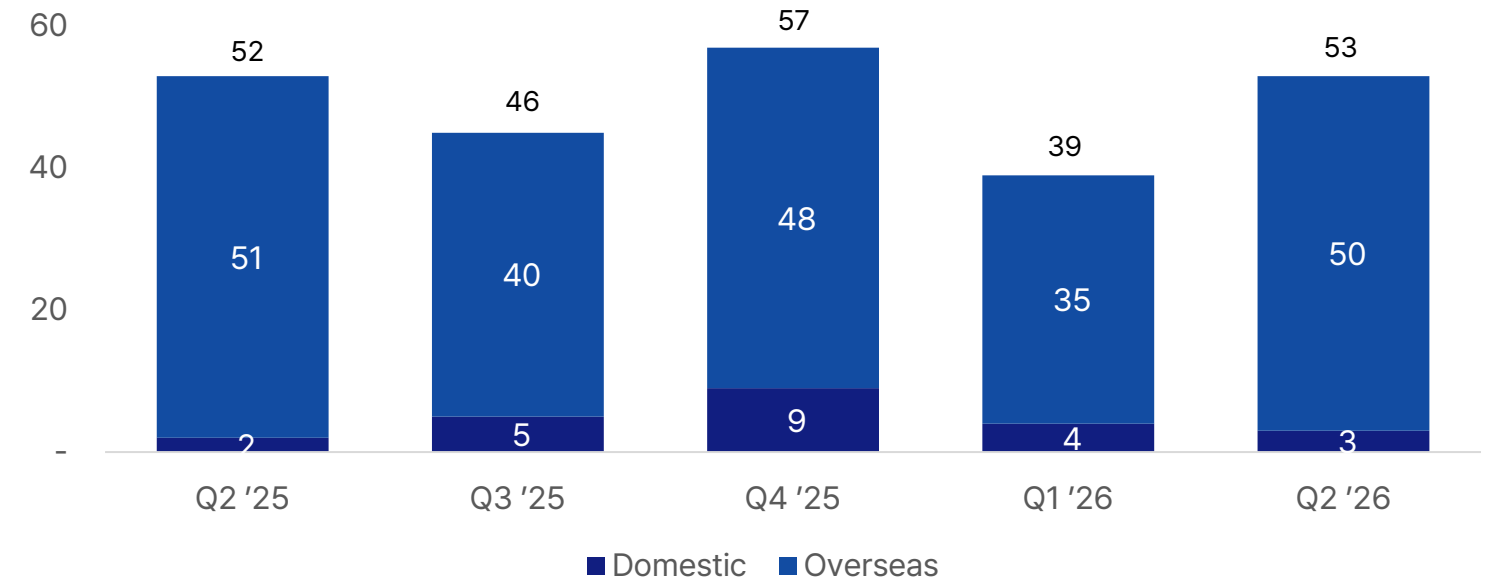
Q2 ‘26 Revenue by Region

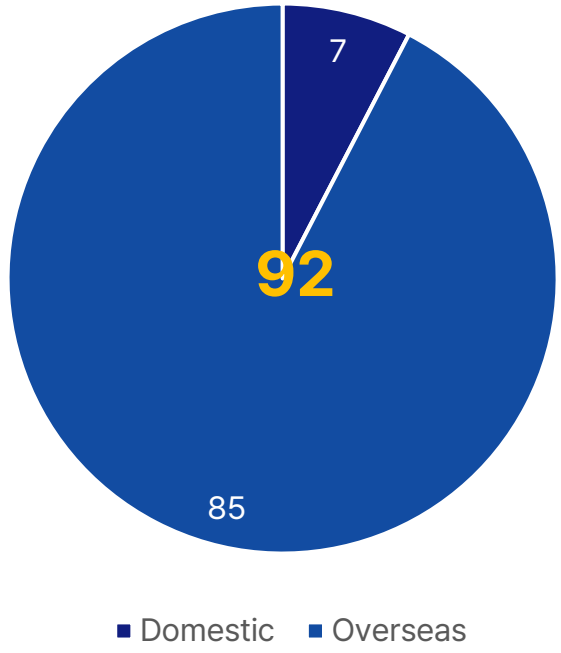
- Year-to-date (YTD) Revenue Distribution: 92B KRW
  - Domestic 8%, Overseas 92%

(Unit: B KRW)



Note : K-IFRS consolidated financial statement basis

(Unit: B KRW)



Note : K-IFRS consolidated financial statement basis

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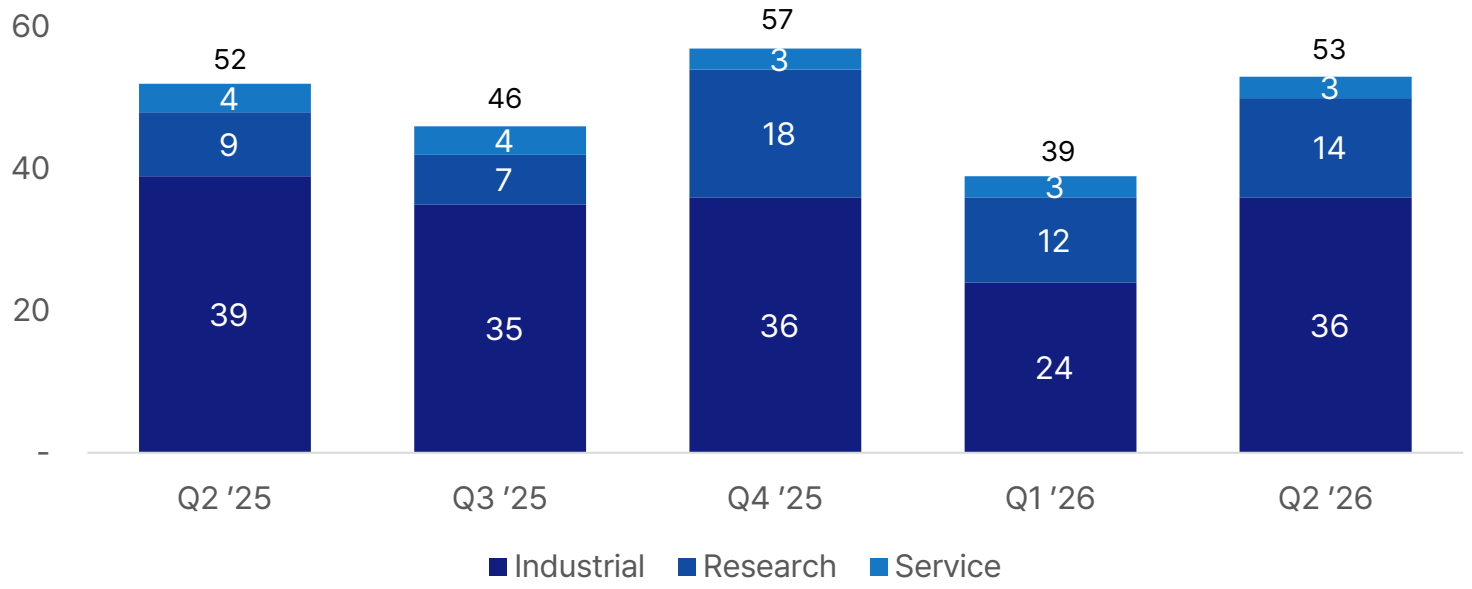
Q2 ‘26 Revenue by Product

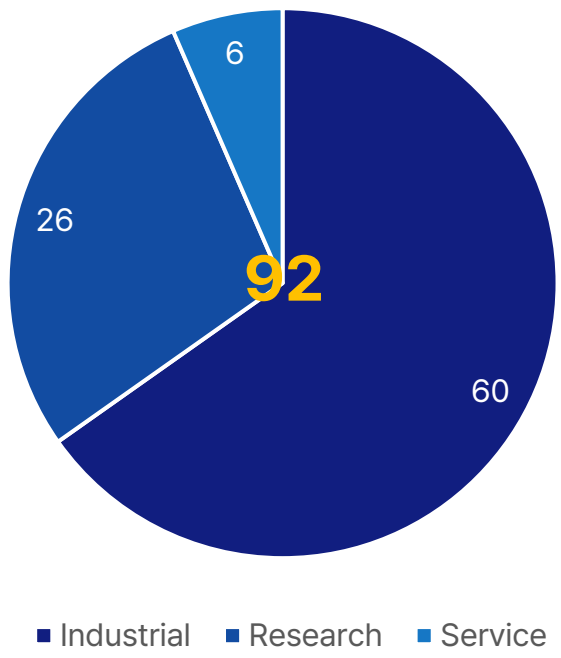
- Year-to-date (YTD) Revenue Distribution: 92B KRW
  - Industrial 65%, Research 28%, Service 7%

(Unit: B KRW)



Note : K-IFRS consolidated financial statement basis

(Unit: B KRW)



Note : K-IFRS consolidated financial statement basis

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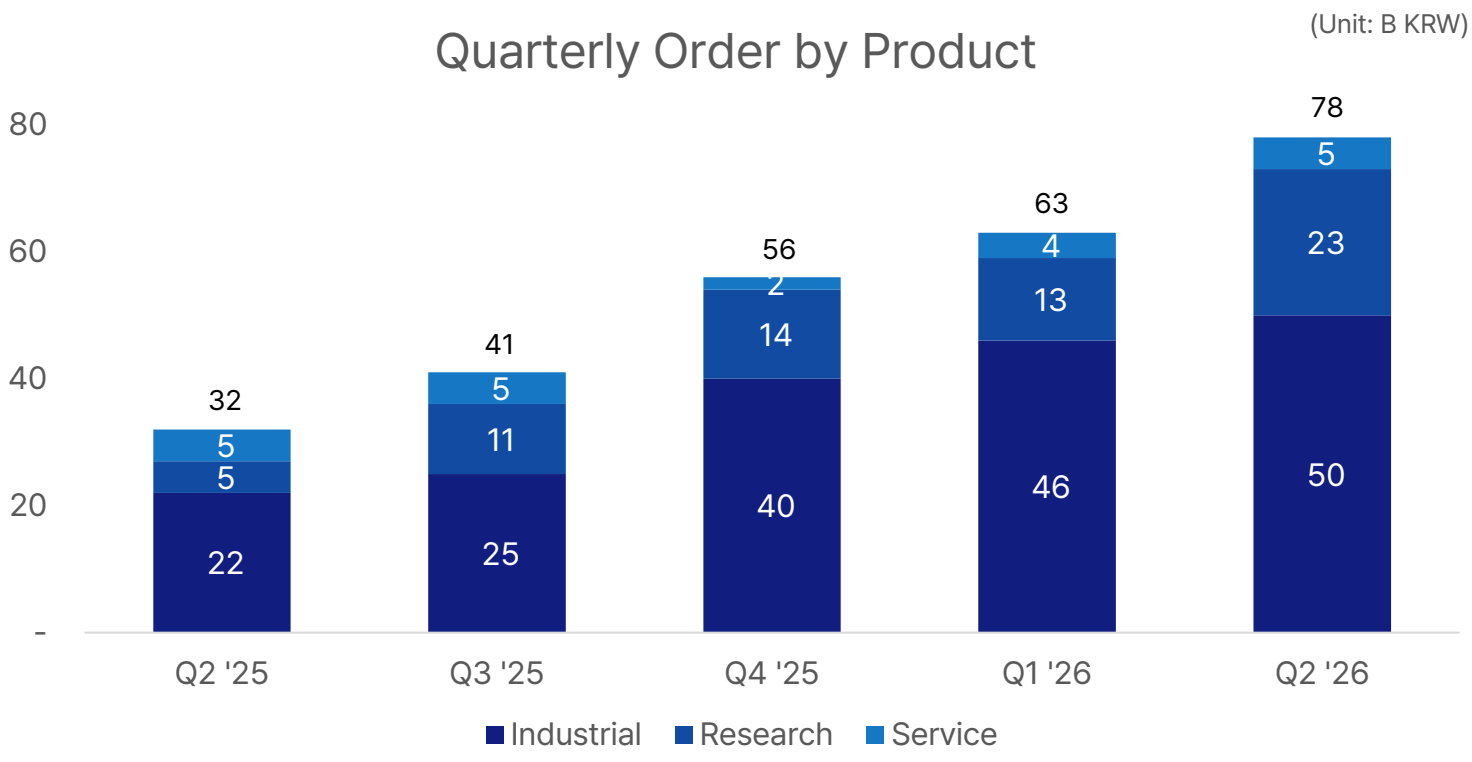
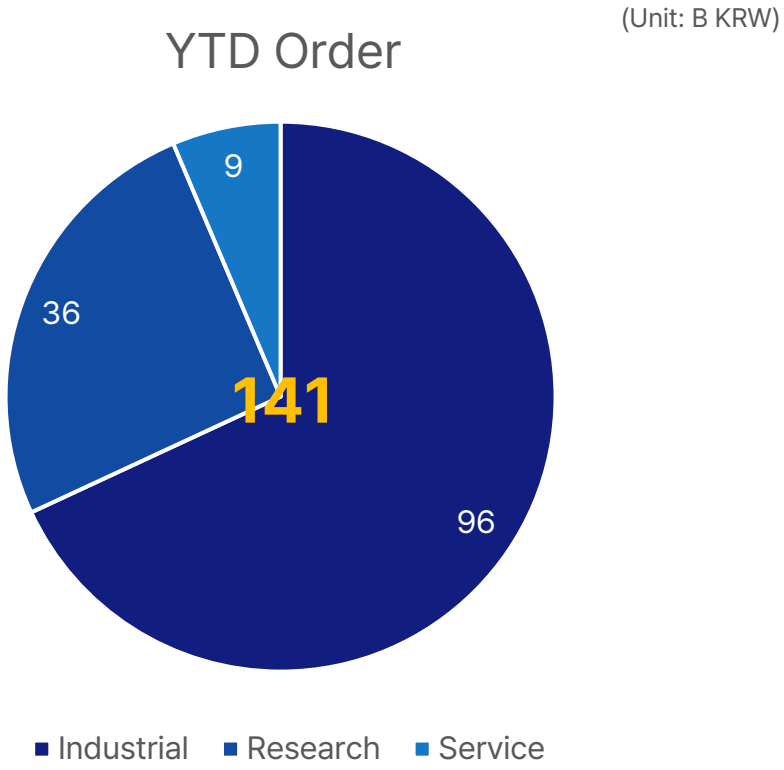
Q2 ‘26 POs by Product

- Year-to-date (YTD) Order Distribution: 63B KRW
  - Industrial 68%, Research 26%, Service 6%





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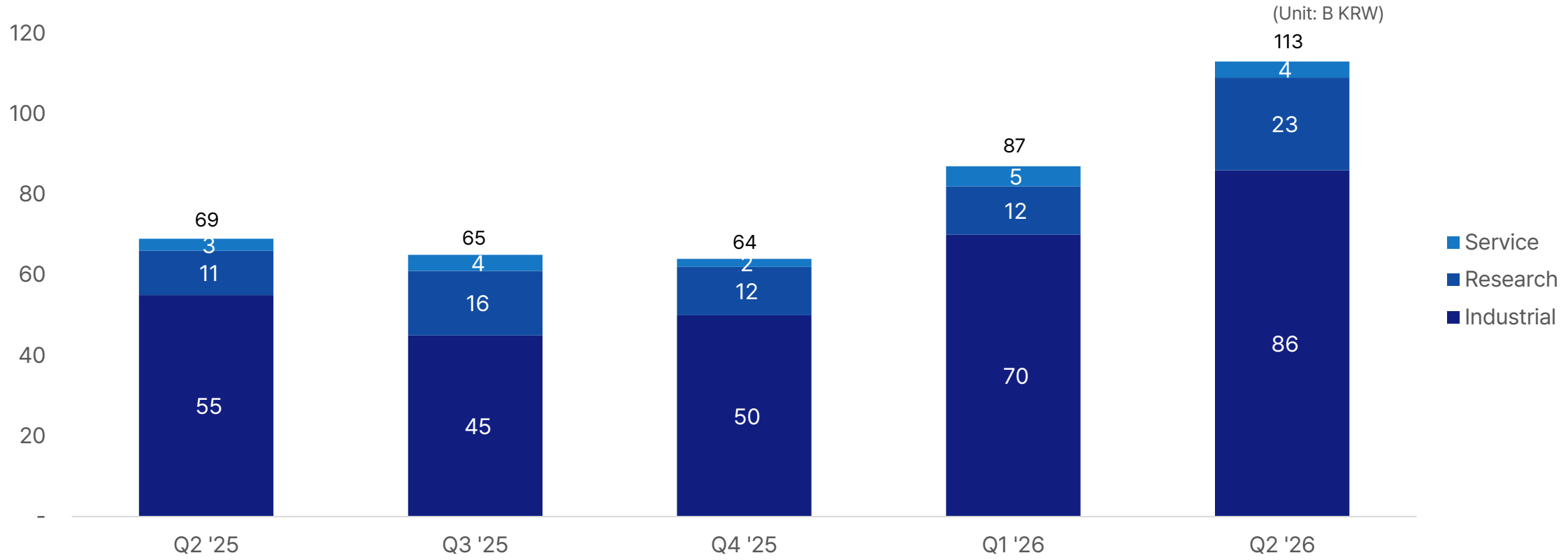
Q2 ‘26 Order Backlog by Product

- Order Backlog: 113B KRW
  - Industrial 76%, Research 20%, Service 4%
  - Order backlog as of the report submission date(Aug.14): 102B KRW



Park Systems
Enabling Nanoscale Advances

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Appendix

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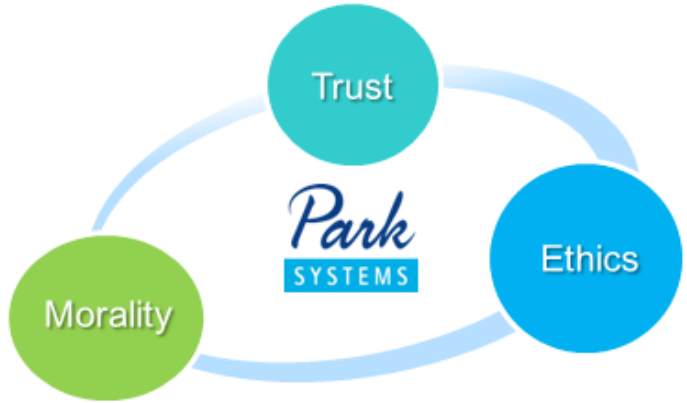
Company Overview

Company Status

Company	Park Systems Corp.
CEO	Sang-il Park
Established	April 7, 1997
Capital	3,498m (KRW) (As of Dec, 2025)
Employees	611 (As of Dec, 2025)
Business field	Precision Instrument Manufacturing
Product	Atomic Force Microscope
Location	KANC 4F, Gwanggyo-ro 109, Yeongtong-gu, Suwon, 16229, Korea
Website	http://www.parksystems.com

Business Philosophy



1. Become the one who receives compliments from people and descendants.
2. Provide maximum value to customers, shareholders, employees and business partners, furthermore, become a company that provides benefits to both companies and the society.
3. Excel in technical development and global marketing.
4. Trust is the best asset, and moral and ethical management are basic.

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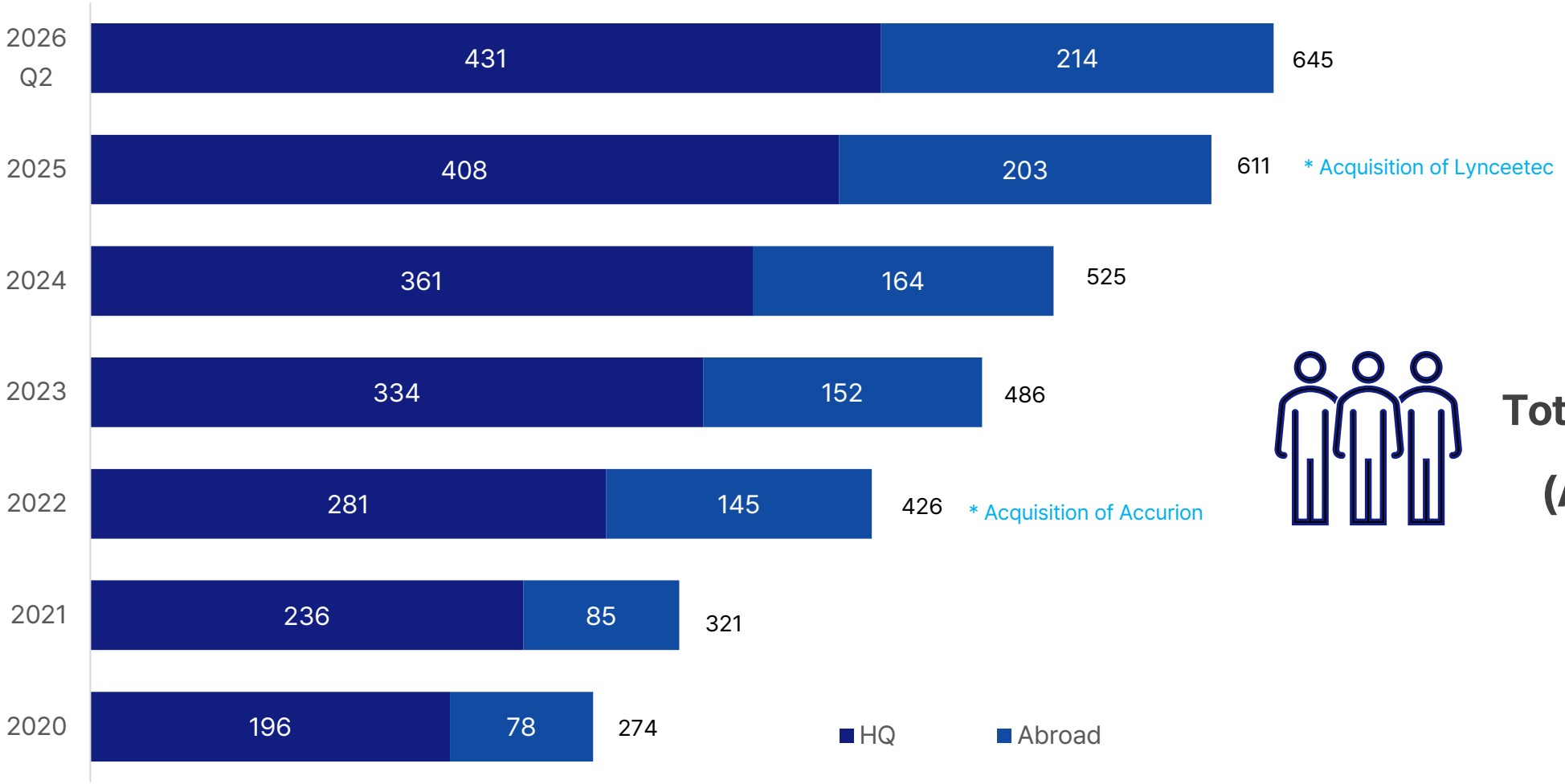
HR

- Numbers of Employees



Total employees : 645

(As of 2026.6.30)

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Financial Statements

- Park Systems continues to experience annual growth of 20-30%.
- Park Systems achieves high-profit margins by supplying high-value-added products.

Unit : M KRW

B/S	2022	2023	2024	2025	2026 H1
Current assets	126,307	148,107	191,151	196,653	**264,878**
Non-current assets	40,742	53,566	83,164	153,269	**209,029**
Total asset	167,049	201,673	274,315	349,922	**473,907**
Current liabilities	39,688	49,665	62,938	73,354	**73,180**
Non-current liabilities	7,898	8,523	23,468	51,449	**60,422**
Total Liabilities	47,586	58,188	86,406	124,803	**133,602**
Capital	3,474	3,483	3,494	3,498	**3,501**
Additional paid in capital	48,146	49,189	50,814	51,809	**159,389**
Others	(1,692)	(523)	2,229	7,436	**10,794**
Retained earnings	69,535	91,336	131,372	162,376	**166,621**
Total equity	119,463	143,485	187,909	225,119	**340,305**

Note : K-IFRS consolidated financial statement basis

Unit : M KRW

I/S	2022	2023	2024	2025	2026 H1
Sales Revenue	124,522	144,806	175,060	205,613	**92,400**
Cost of goods sold	43,053	52,401	60,842	69,121	**29,018**
Operating expenses	48,821	64,845	75,688	94,301	**57,067**
Operating profit	32,648	27,560	38,530	42,191	**6,315**
Non-operating profit	11,332	6,662	14,788	11,614	**7,738**
Non-operating expenses	12,099	7,079	6,088	12,581	**4,754**
Profit before tax	31,881	27,143	47,230	41,224	**9,299**
Tax expenses	3,897	2,581	4,427	6,748	**1,580**
Net income	27,984	24,562	42,803	34,476	**7,719**

Note : K-IFRS consolidated financial statement basis

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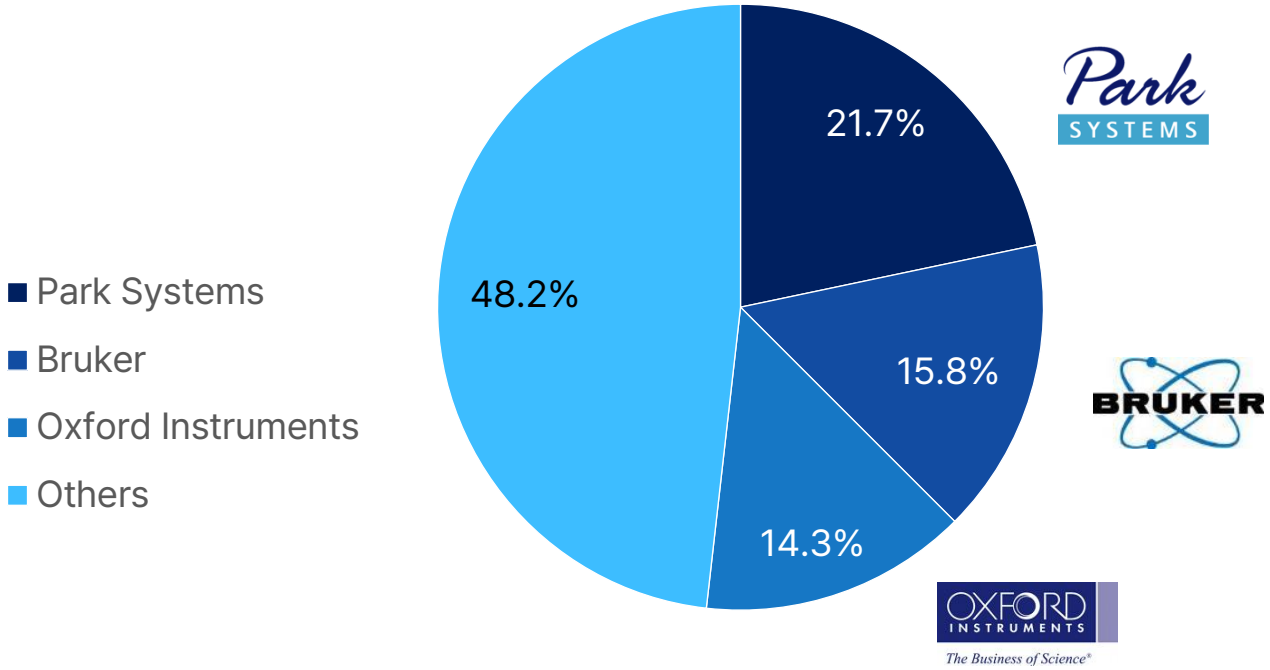
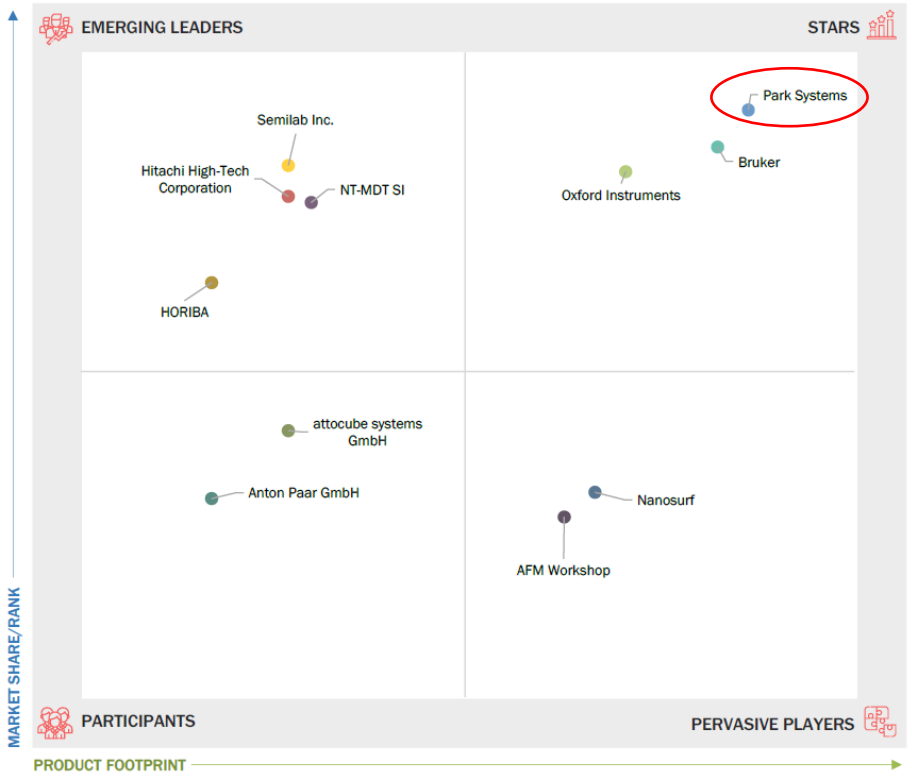
AFM Market

- Park Systems holds the No.1 position in the AFM market.
- The AFM market is expected to grow steadily, driven by increasing demand for industrial equipment.

AFM Market Share 2024





Source: Annual Reports, Press Releases, Investor Presentations, Interviews with Experts, and Markets and Markets Analysis

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Launch of the Third JDP with imec(Apr. 20)

Park Systems Invests in Advanced Metrology Portfolio for 3D Packaging and Logic Research



Third JDP with imec
→ Joint development of next-generation semiconductor metrology

AFM-based metrology portfolio
→ AFM, WLI, ISE, and DHM applications

3D packaging & logic devices
→ Validation using imec's advanced samples

Expanded collaboration
→ Development of integrated metrology solutions

Joined imec 3D Systems Integration IIAP
→ Strengthening long-term collaboration in advanced packaging

source: https://www.parksystems.com/en/news-events/news/news-details.park-systems-jpd-imec

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Launch of Park NX1 (Apr. 30)

Park Systems Launches NX1: The Highest Resolution AFM for Atomic-Scale Imaging in Ambient Conditions



Atomic-scale imaging under ambient conditions
→ Extends ultra-high-resolution AFM imaging beyond UHV environments

Park Systems' precision AFM engineering
→ Commercialized as the reliable and user-friendly NX1

High-sensitivity sensing & probe support
→ Supports silicon probes and qPlus® sensors

Improved usability
→ Easy probe replacement and SmartScan™ / SmartAnalysis™ integration

Source: https://www.parksystems.com/en/news-events/news/news-details.park-systems-launches-nx-1

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KRW 100 Billion Funding (May.21)

- **Perpetual Bonds with Warrants**
  - Total electronically registered bond amount: KRW 100,000,000,000
  - Issue price: 100% of the total electronically registered bond amount (discount rate: 0.00%)
  - Bond interest rate: Coupon rate: 0.0%, YTM: 0.0%
  - Beginning on the third anniversary of the issuance date, an annual compound interest rate of 3.0% will be added to the YTM. Thereafter, an additional annual compound interest rate of 1.0% will be added each year to the previously adjusted YTM.
- **Warrants**
  - Exercise Period: June 8, 2027 – May 8, 2056.
  - Exercise Price: KRW 267,747
- **Call Option**
  - Exercisable every three months from June 8, 2027, through June 8, 2029
  - Amount: up to 20% of the total bond issuance amount
  - The purchase price of the bonds shall be calculated based on a guaranteed YTM of 0.0%

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2026 Investor Day(May.29)



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Active Marketing Activities



Tradeshow

IMRC Cancun 2026

Aug 17, 2026 - Aug 22, 2026
Cancun, Mexico

Join Park Systems at IMRC Cancun 2026 and discover our advanced portfolio of nanoscale...

View Details ›



Tradeshow

21st International Microscopy Congress (IMC21) 2026

Aug 31, 2026 - Sep 05, 2026
Liverpool, UK

Park Systems will participate as an exhibitor at the 21st International Microscopy Congress...

View Details ›



Tradeshow

SEMICON Taiwan 2026

Sep 02, 2026 - Sep 04, 2026
Taiwan

SEMICON Taiwan brings together the global semiconductor community to explore the...

View Details ›



Webinar

Nanoscale Surface Analysis on Battery Materials via Atomic Force Microscopy

Sep 02, 2026 - Sep 02, 2026

View Details ›



Tradeshow

SPIE Photomask 2026

Sep 11, 2026 - Sep 12, 2026
Monterey, CA, US

Join Park Systems at SPIE Photomask 2026 and discover our advanced portfolio of...

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Webinar

Piezoresponse Force Microscopy: Techniques, Advances, and Recent Applications

Oct 13, 2026 - Oct 13, 2026

View Details ›

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Thank you

Park Systems

IR Team

ir@parksystems.com

02-2660-6401